Semiconductor Detector Lab







Infrastructure and expertise for the development and production of semiconductor-based radiation detectors and detection systems

Chemical processing,

ptolithography, wire bonding

Semiconductor Detector Lab





Ortho-strip Ge array for gamma tracking, imaging, and spectroscopy

Point-contact Ge for lownoise spectroscopy with multi-site event rejection





Strip Ge for light sources

CdZnTe array for gamma imaging and spectroscopy



- Facilities: class 100 clean room, class 10,000 processing and testing area, mechanical processing area
- Processes: mechanical and wet chemical processing, thin film deposition, photolithography, wire bonding, detector characterization
- Detector materials: Ge, CdZnTe, and Si
- Technologies: diffused, implanted, surface barrier, and amorphous contacts; strip, orthogonal strip, point contact, and other unique configurations
- Application areas: nuclear science, space science, x-ray light source science, homeland security, nonproliferation, medical imaging